

2829



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Woo Sik Yoo  
Assignee: WaferMasters, Inc.  
Title: Method for Ultra-Thin Film Formation  
Serial No.: 09/775,835 Filing Date: January 31, 2001  
Examiner: Lisa A. Kilday Group Art Unit: 2829  
Docket No.: M-8250 US

Irvine, California  
May 8, 2003

Mail Stop DD  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §1.97**

Dear Sir:

Pursuant to 37 C.F.R. §1.97, Applicant wishes to call the following documents (copies enclosed) to the attention of the Examiner. The documents were cited in the PCT Search Report for the corresponding PCT Application No. PCT/US02/02387, on February 21, 2003.

1. A PTO form 1449 listing these documents is enclosed.

The relevance of any non-English language documents cited herein is explained in the accompanying copy of the Search Report.

Citation of the above documents shall not be construed as:

1. an admission that the documents are necessarily prior art with respect to the instant invention;
2. a representation that a search has been made, or

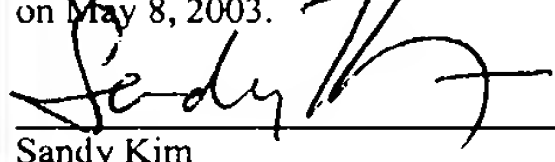
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3. an admission that the information cited herein is, or is considered to be material to patentability as defined in §1.56(b).

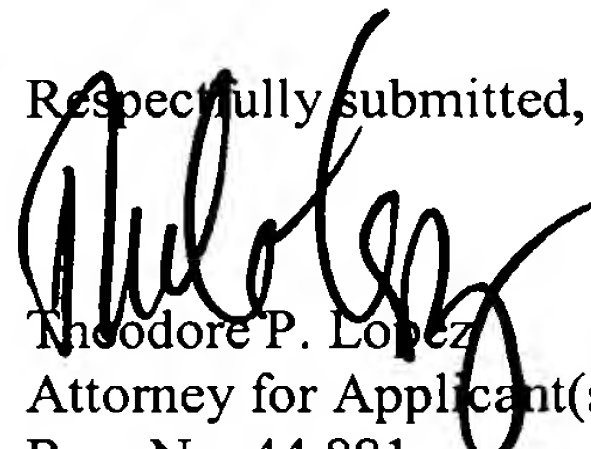
The undersigned hereby certifies in accordance with §1.97(e)(1) that each item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this information disclosure statement.

Applicant(s) believes that no fee is required for submission of this statement. However, if a fee is required, the Commissioner is authorized to deduct such fee from the undersigned's Deposit Account No. 50-2257. Please deduct any additional fees from, or credit any overpayment to the above-noted Deposit Account.

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on May 8, 2003.

  
Sandy Kim

May 8, 2003.  
Date of Signature

Respectfully submitted,  
  
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Sheet 1 of 1

U.S. Department of Commerce, Patent and Trademark Office					Atty Docket No.		Serial No.	
					M-8250 US		09/775,835	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT					Applicant(s)			
(Use several sheets if necessary)					Woo Sik Yoo			
					Filing Date		Group	
					January 31, 2001		2829	
U.S. Patent Documents								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA	6,171,104	01/09/2001	Saito et al.	432	18		
	AB	5,947,675	09/07/99	Matsushima	414	416		
	AC	5,946,588	08/31/99	Ahmad et al.	438	585		
	AD	5,880,041	03/09/99	Ong	438	773		
	AE	5,8963,843	01/26/99	Green et al.	438	771		
	AF	5,296,412	03/22/94	Ohsawa	437	247		
	AG	4,99,247	07/8/1986	Bean et al.	427	93		
Foreign Patent Documents								
							Translation	
		Document	Date	Country	Class	Subclass	Yes	No
	AH	WO 01/41197	06/07/2001	PCT				
	AI							
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)								
	AJ							
	AK							
Examiner			Date Considered					
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.								

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